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|-----------------------------------------------------------------------------------|-------------------------|-----------------------------------------|
| Search Notes | Application/Control No. | Applicant(s)/Patent Under Reexamination |
|  | 10796864 | LIANG, CHENG-CHUNG |
| Examiner | Art Unit | |
| Radkiewicz, Jared W | 2609 | |

SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|-----------|----------|
| 382 | 173 | 5/31/2007 | JWR |

SEARCH NOTES

| Search Notes | Date | Examiner |
|--------------------------------------------|-----------|----------|
| Keyword limit searched 382/154 and 183/173 | 5/31/2007 | JWR |

INTERFERENCE SEARCH

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